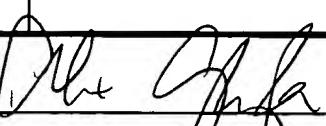


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				Katherine GILES					
				FILING FEB. 26, 2001		GROUP TO BE ASSIGNED			
U.S. PATENT DOCUMENTS									
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
NO PIRE PTM TRADEMARK DE		4,894,254	1/16/90	NAKAYAMA et al.					
		4,822,632	4/18/89	WILLIAMS et al.					
		4,096,315	6/20/78	KUBACKI					
		5,786,039	7/28/98	BROUQUET					
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		5,494,712	2/27/96	HU et al.					
		5,314,724	5/24/94	TSUKUNE et al.					
		5,273,851	12/28/93	TAKEI et al.					
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AC		5,730,804	3/24/98	GOMI et al.					
		FOREIGN PATENT DOCUMENTS							
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								YES	NO
			WO 99/41423	8/19/99	PCT			<input checked="" type="checkbox"/>	<input type="checkbox"/>
			EP 0 826 791 A	3/4/98	EPO			<input checked="" type="checkbox"/>	<input type="checkbox"/>
			EP 0 519 079 A	12/23/92	EPO			<input checked="" type="checkbox"/>	<input type="checkbox"/>
			DE 196 54 737 A1	7/3/97	GERMANY			<input checked="" type="checkbox"/>	<input type="checkbox"/>
			WO 98/08249 A	2/26/98	PCT			<input checked="" type="checkbox"/>	<input type="checkbox"/>
		OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
		A. Grill et al., "Low Dielectric Constant Films Prepared by Plasma-Enhanced Chemical Vapor Deposition from Tetramethylsilane" Journal of Applied Physics, US, American Institute of Physics, New York, vol. 85, no. 6, 15 March 1999, pages 3314-3318.							
		Patent Abstracts of Japan, vol. 1999, no. 02, 26 February 1999 & JP 10 310866 A, 24 November 1998, abstract.							
EXAMINER			DATE CONSIDERED						
									
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AC	5,620,524	4/15/97	FAN et al.			
OIA	5,534,069	7/9/96	KUWABARA et al.			
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	4,793,524	12/27/88	STARR			
AC	3,223,040	12/14/65	DINKELKAMP			

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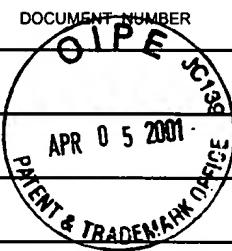
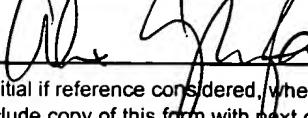
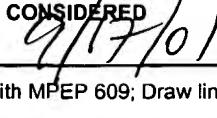
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AC	WO 99/43866	9/2/99	PCT			✓	
	GB 2111064 A	6/29/83	UK			✓	
	GB 2108133 A	5/11/83	UK			✓	
	0 826 791 A2	3/4/98	EPO			✓	
AC	0 726 599 A2	8/14/96	EPO			✓	

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FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
AG		0 254 205 A2	7/19/86	EPO			✓	
		0 212 691 A1	3/4/97	EPO			✓	
		WO 94/01885	1/20/94	PCT			✓	
		GB 2280169 A	1/25/95	UK			✓	
AG		GB 2220869 A	1/24/90	UK			✓	
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